

Docket No. 42479-9400

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Satoshi Hayashi et al.

Serial No.: 10/581,578

Filed: December 26, 2006

For: ANION ADSORBING CARBON MATERIAL,  
AS WELL AS MANUFACTURING METHOD  
AND MANUFACTURING FACILITIES FOR  
SAME

Group Art Unit: 1793

Confirmation No.: 4920

June 3, 2008

Costa Mesa, California 92626

SUPPLEMENTAL  
INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following reference which was found during the prosecution of a co-pending Chinese patent application:

Chinese Publication No. 1040185A w/English translation of claims.

A copy of the reference and Form PTO-A820 are attached.

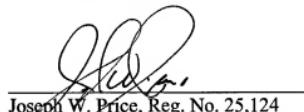
The undersigned attorney hereby certifies that each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing the information disclosure statement.

Docket No. 42479-9400

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

**SNELL & WILMER L.L.P.**

  
\_\_\_\_\_  
Joseph W. Price, Reg. No. 25,124  
600 Anton Boulevard, Suite 1400  
Costa Mesa, CA 92626-7689  
Tel: 714-427-7420  
Fax: 714-427-7799

Receipt date: 06/03/2000

16521578 - GAU. 4181

**INFORMATION DISCLOSURE CITATION**  
*(Use several sheets if necessary)*

Docket Number (Optional)

42479-9400

Application Number

10/581,578

Applicant(s)

Satoshi Hayashi et al.

Filing Date

December 26, 2006

Group Art Unit

1793

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**U. S. PATENT APPLICATION PUBLICATIONS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	1040185A	3.7.1990	China w/English translation of claims			X	

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER /Brian Walck/ DATE CONSIDERED 01/31/2009

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.